

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3681	(dual (two adj layer)) near2 ((insulat\$4 dielectric) adj (film layer))	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2007/09/23 13:23
L2	3093	L1 and (@ad<"20040419" @rlad<"20040419")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2007/09/23 13:25
L3	1638	L2 and (((silicon adj nitride) SiN "Si.sub.3N.sub.4")) and (((silicon adj (dioxide oxide)) "SiO.sub.2" "SiO.sub.x"))	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2007/09/23 13:30
L4	570	L3 and ((gate adj insulat\$4) same ((silicon adj (oxide dioxide)) "SiO.sub.2" "SiO.sub.x"))	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2007/09/23 13:38
L5	1	09/527534	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2007/09/23 13:38